

Ref: IIT/KGP/S&P/CRF/FESEM/2018-19,Date: 11-10-2018

**Variable pressure High resolution Field Emission Scanning Electron Microscope with
EDS and EBSD Facility**

Date: 08.11.2018

Corrigendum

DEADLINE:

Last Date and Time for submitting the tender document has been extended from 09.11.2018 to **16.11.2018 at 11:30 Hrs.**

Time and Date of Opening of Technical Bids has been extended from 12.11.2018 to **21.11.2018 at 15:30 Hrs**

Copy to: 1. Institute website, 2. CPP Portal